



UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/623,866 Confirmation No. : 6399  
First Named Inventor : Yoshihiro KATO  
Filed : July 22, 2003  
TC/A.U. : 1763  
Examiner : J. Lund

Docket No. : 101246.52582US  
Customer No. : 23911

Title : Plasma Process System and Plasma Process Method

**REPLY**

**Mail Stop AMENDMENT**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are respectfully submitted in response to the non-final Office Action dated July 25, 2007, the period for response having been extended to November 25, 2007 by the attached Petition for Extension of Time. **An extension of the deadline for response to the Office Action is respectfully requested pursuant to 37 C.F.R. § 1.136(a) and the appropriate fee is submitted herewith.**

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper. ***No additional claims fees are due.***

**Remarks** begin on page 10 of this paper.